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Michael R

ated: August 25, 2005

Signature:

Docket No.: 29936/39432

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e Patent Application of:

ung Hoon Lee

Application No.: 10/628,803

Confirmation No.: 4537

Filed: July 28, 2003

Art Unit: 1765

For: METHOD OF FORMING ISOLATION FILM

Examiner: Van Linh

OF SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

The undersigned hereby verifies that this statement is filed within three months of the issuance of a Chinese Patent Office Action from the Chinese Patent Office in connection with Chinese Patent Application No. 200310120669.6, which is based on Korean Patent Application No. 2002-85460, which is the priority application for the present application. Accordingly, this statement complies with 1.97 (c)(1) and 1.97(e)(1) and no fee is due.

A copy of each reference on the PTO/SB/08 is attached.

Application No.: 10/628,803 Docket No.: 29936/39432

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 13-2855, under Order No. 29936/39432.

Dated: August 25, 2005

Respectfully submitted,

Michael R. Hull

Registration No.: 35,902

MARSHALL, GERSTEIN & BORUN LLP

233_8. Wacker Drive, Suite 6300

Sears Tower

Chicago, Illinois 60606-6357

(312) 474-6300

Attorney for Applicant

PTO/SB/08a/b (08-03)
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1

Complete if Known				
Application Number	10/628,803-Conf. #4537			
Filing Date	July 28, 2003			
First Named Inventor	Sung H. Lee			
Art Unit	1765			
Examiner Name	Lan Vinh			
Attorney Docket Number	29936/39432			

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		JP 11-87489	03-30-1999	Asahi Chem. Ind. Co. Ltd	English Abstract and Japanese Publication	

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		Office Action from Chinese Patent Office dated July, 2005 and accompanying letter from Chinese Associate regarding the same			

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Examiner		Date	
Signature		 Considered	<u> </u>
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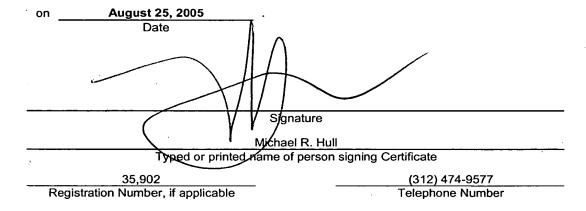
Application No. (if known): 10/628,803

Attorney Docket No.: 29936/39432

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IDS (Citation) by Applicant (2 References) (1 page) Information Disclosure Statement